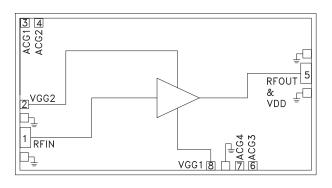


Typical Applications

The HMC797 is ideal for:

- Test Instrumentation
- Microwave Radio & VSAT
- Military & Space
- Telecom Infrastructure
- Fiber Optics

Functional Diagram



Features

High P1dB Output Power: +28 dBm High Psat Output Power: +31 dBm

High Gain: 14.5 dB

High Output IP3: +40 dBm

Supply Voltage: +10 V @ 400 mA 50 Ohm Matched Input/Output
Die Size: 2.89 x 1.55 x 0.1 mm

General Description

The HMC797 is a GaAs MMIC PHEMT Distributed Power Amplifier die which operates between DC and 22 GHz. The amplifier provides 14.5 dB of gain, 40 dBm output IP3 and +28 dBm of output power at 1 dB gain compression while requiring 400mA from a +10V supply. This versatile PA exhibits a positive gain slope from 3 to 21 GHz making it ideal for EW, ECM, Radar and test equipment applications. The HMC797 amplifier I/Os are internally matched to 50 Ohms facilitating integration into Mutli-Chip-Modules (MCMs). All data is taken with the chip connected via two 0.025mm (1 mil) wire bonds of minimal length 0.31 mm (12 mils).

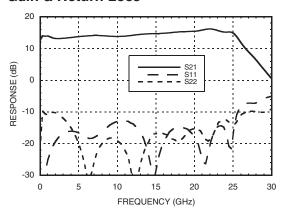
Electrical Specifications, $T_A = +25^{\circ}$ C, Vdd = +10V, Vgg2 = +3.5V, Idd = 400 mA*

Parameter	Min.	Тур.	Max.	Min.	Тур.	Max.	Min.	Тур.	Max.	Units
Frequency Range		DC - 10			10 - 18			18 - 22		GHz
Gain		13.5			14.5			15.5		dB
Gain Flatness		±0.5			±0.7			±0.4		dB
Gain Variation Over Temperature		0.009			0.01			0.012		dB/ °C
Input Return Loss		16			17			18		dB
Output Return Loss		16			18			17		dB
Output Power for 1 dB Compression (P1dB)	27	28.5		27	28.5		26.5	28		dBm
Saturated Output Power (Psat)		31			31			31		dBm
Output Third Order Intercept (IP3)		41			40			39		dBm
Noise Figure		3.5			3			3.5		dB
Supply Current (Idd) (Vdd= 10V, Vgg1= -0.8V Typ.)		400			400			400		mA

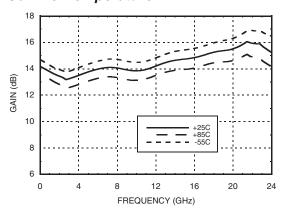
^{*} Adjust Vgg1 between -2 to 0V to achieve Idd = 400 mA typical.



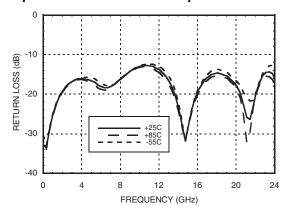
Gain & Return Loss



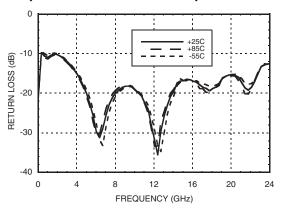
Gain vs. Temperature



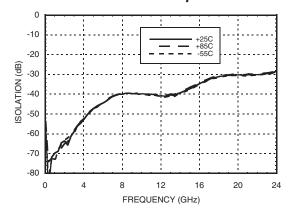
Input Return Loss vs. Temperature



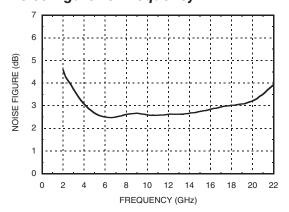
Output Return Loss vs. Temperature



Reverse Isolation vs. Temperature

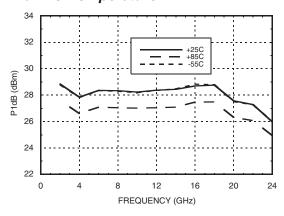


Noise Figure vs. Frequency

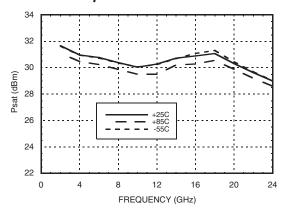




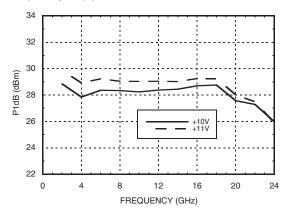
P1dB vs. Temperature



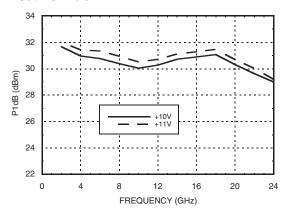
Psat vs. Temperature



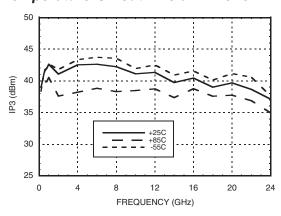
P1dB vs. Vdd



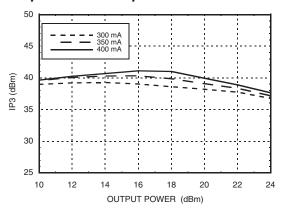
Psat vs. Vdd



Output IP3 vs.
Temperature @ Pout = 18 dBm Tone

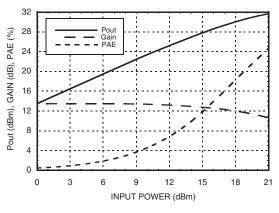


Output IP3 vs. Output Power @ 10 GHz

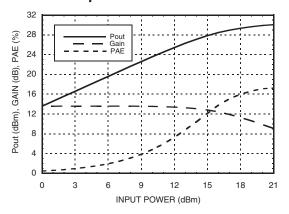




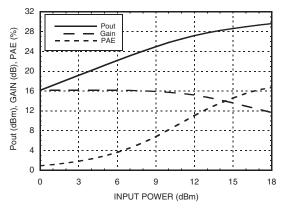
Power Compression @ 2 GHz



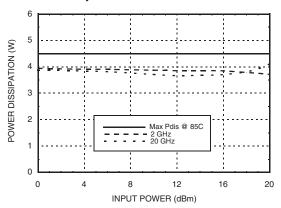
Power Compression @ 10 GHz



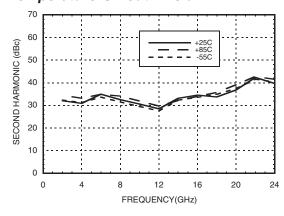
Power Compression @ 22 GHz



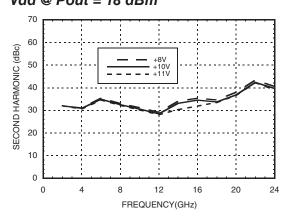
Power Dissipation



Second Harmonics vs. Temperature @ Pout = 18 dBm

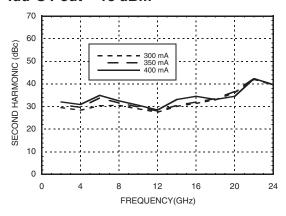


Second Harmonics vs. Vdd @ Pout = 18 dBm

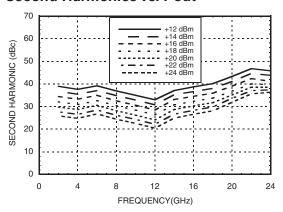




Second Harmonics vs. Idd @ Pout = 18 dBm



Second Harmonics vs. Pout



Absolute Maximum Ratings

Drain Bias Voltage (Vdd)	+12 Vdc
Gate Bias Voltage (Vgg1)	-3 to 0 Vdc
Gate Bias Voltage (Vgg2)	Vgg2 = (Vdd -6.5V) to 4.5V. For Vdd <8.5V, Vgg2 must remain >2V
RF Input Power (RFIN)	+27 dBm
Channel Temperature	150 °C
Continuous Pdiss (T= 85 °C) (derate 69 mW/°C above 85 °C)	4.5 W
Thermal Resistance (channel to die bottom)	14.5 °C/W
Output Power into VSWR >7:1	29 dBm
Storage Temperature	-65 to 150°C
Operating Temperature	-55 to 85 °C

Typical Supply Current vs. Vdd

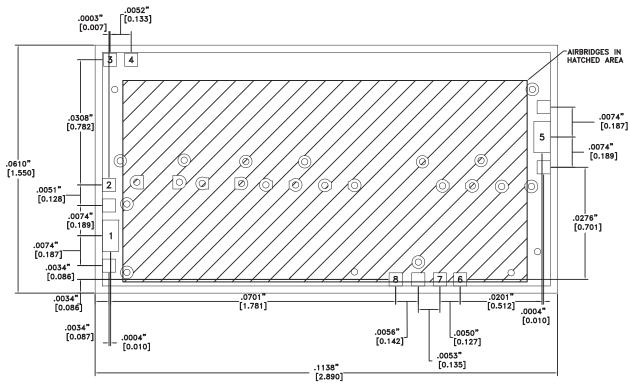
Vdd (V)	Idd (mA)
+9	400
+10	400
+11	400



ELECTROSTATIC SENSITIVE DEVICE OBSERVE HANDLING PRECAUTIONS



Outline Drawing



This die utilizes fragile air bridges. Any pick-up tools used must not contact the die in the cross hatched area.

Die Packaging Information [1]

Standard	Alternate
WP-19 (Waffle Pack)	[2]

- [1] Refer to the "Packaging Information" section on our website for die packaging dimensions.
- [2] For alternate packaging information contact Hittite Microwave Corporation.

NOTES:

- 1. ALL DIMENSIONS ARE IN INCHES [MM]
- 2. DIE THICKNESS IS .004"
- 3. TYPICAL BOND PAD IS .004" SQUARE
- 4. BOND PAD METALIZATION: GOLD
- 5. BACKSIDE METALIZATION: GOLD
- 6. BACKSIDE METAL IS GROUND
- 7. NO CONNECTION REQUIRED FOR UNLABELED BOND PADS
- 8. OVERALL DIE SIZE ±.002"

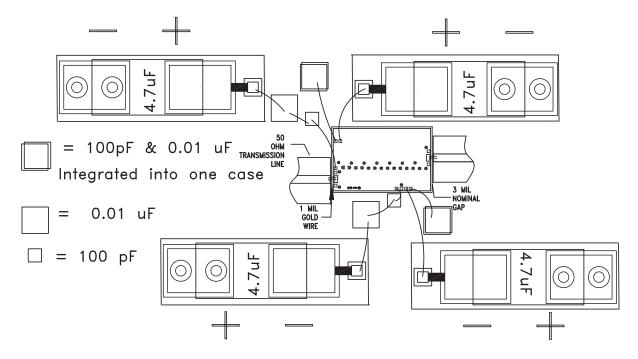


Pad Descriptions

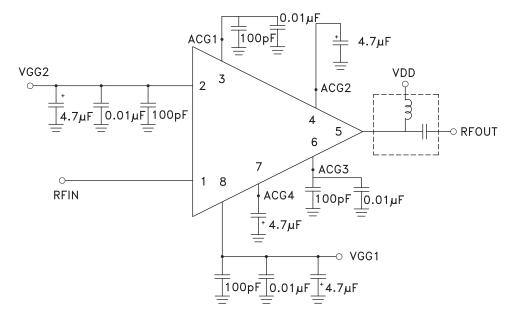
Pad Number	Function	Description	Interface Schematic
1	RFIN	This pad is DC coupled and matched to 50 Ohms. Blocking capacitor is required.	RFIN O
2	VGG2	Gate control 2 for amplifier. Attach bypass capacitors per application circuit herein. For nominal operation +3.5V should be applied to Vgg2.	VGG20
4, 7	ACG2, ACG4	Low frequency termination. Attach bypass capacitors per application circuit herein.	
3	ACG1	Low frequency termination. Attach bypass capacitors per application circuit herein.	ACG1 0-VV- RFOUT
5	RFOUT & VDD	RF output for amplifier. Connect DC bias (Vdd) network to provide drain current (Idd). See application circuit herein.	& ∨DD
6	ACG3	Low frequency termination. Attach bypass capacitor per application circuit herein.	IN O ACG3
8	VGG1	Gate control 1 for amplifier. Attach bypass capacitor per application circuit herein. Please follow "MMIC Amplifier Biasing Procedure" application note.	VGG10
Die Bottom	GND	Die bottom must be connected to RF/DC ground.	



Assembly Diagram



Application Circuit



NOTE 1: Drain Bias (Vdd) must be applied through a broadband bias tee with low series resistance and capable of providing 500mA



Mounting & Bonding Techniques for Millimeterwave GaAs MMICs

The die should be attached directly to the ground plane eutectically or with conductive epoxy (see HMC general Handling, Mounting, Bonding Note).

50 Ohm Microstrip transmission lines on 0.127mm (5 mil) thick alumina thin film substrates are recommended for bringing RF to and from the chip (Figure 1). If 0.254mm (10 mil) thick alumina thin film substrates must be used, the die should be raised 0.150mm (6 mils) so that the surface of the die is coplanar with the surface of the substrate. One way to accomplish this is to attach the 0.102mm (4 mil) thick die to a 0.150mm (6 mil) thick molybdenum heat spreader (moly-tab) which is then attached to the ground plane (Figure 2).

Microstrip substrates should be placed as close to the die as possible in order to minimize bond wire length. Typical die-to-substrate spacing is 0.076mm to 0.152 mm (3 to 6 mils).

Handling Precautions

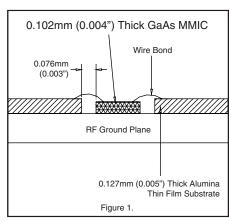
Follow these precautions to avoid permanent damage.

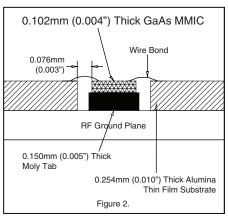
Storage: All bare die are placed in either Waffle or Gel based ESD protective containers, and then sealed in an ESD protective bag for shipment. Once the sealed ESD protective bag has been opened, all die should be stored in a dry nitrogen environment.

Cleanliness: Handle the chips in a clean environment. DO NOT attempt to clean the chip using liquid cleaning systems.

Static Sensitivity: Follow ESD precautions to protect against ESD strikes.

Transients: Suppress instrument and bias supply transients while bias is applied. Use shielded signal and bias cables to minimize inductive pickup.





General Handling: Handle the chip along the edges with a vacuum collet or with a sharp pair of bent tweezers. The surface of the chip may have fragile air bridges and should not be touched with vacuum collet, tweezers, or fingers.

Mounting

The chip is back-metallized and can be die mounted with AuSn eutectic preforms or with electrically conductive epoxy. The mounting surface should be clean and flat.

Eutectic Die Attach: A 80/20 gold tin preform is recommended with a work surface temperature of 255 °C and a tool temperature of 265 °C. When hot 90/10 nitrogen/hydrogen gas is applied, tool tip temperature should be 290 °C. DO NOT expose the chip to a temperature greater than 320 °C for more than 20 seconds. No more than 3 seconds of scrubbing should be required for attachment.

Epoxy Die Attach: Apply a minimum amount of epoxy to the mounting surface so that a thin epoxy fillet is observed around the perimeter of the chip once it is placed into position. Cure epoxy per the manufacturer's schedule.

Wire Bonding

RF bonds made with two 1 mil wires are recommended. These bonds should be thermosonically bonded with a force of 40-60 grams. DC bonds of 0.001" (0.025 mm) diameter, thermosonically bonded, are recommended. Ball bonds should be made with a force of 40-50 grams and wedge bonds at 18-22 grams. All bonds should be made with a nominal stage temperature of 150 °C. A minimum amount of ultrasonic energy should be applied to achieve reliable bonds. All bonds should be as short as possible, less than 12 mils (0.31 mm).



Notes: